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To: Examiner Mohamedulla, Saleha R. 703-872-9306 / 571-272-1387  
USPTO (Art Unit 1756)

FROM: LEONID D. THENOR  
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DATE: MAY 12, 2005

Note: RE: Application Serial No. 09/722,400

The undersigned hereby states that the Transmittal Letter, Petition for Extension of Time, and Response have been transmitted via facsimile to the centralized facsimile number at the U.S. Patent and Trademark Office on May 12, 2005.

Leonid D. Thenor

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MAY 12 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
Attorney Docket No. 100718.124 (MIC-58DV2)

Inventor: Tianhong Zhang et al. ) Examiner: Mohamedulla, Saleha R.

Serial No. 09/722,400 ) Art Unit: 1756

Filing Date: November 27, 2000 )

For: POLYIMIDE AS A MASK IN VAPOR HYDROGEN FLUORIDE ETCHING

Assistant Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

RESPONSE

In response to the Office Action of November 12, 2004, favorable reconsideration is respectfully requested in view of the following remarks.

Remarks/Arguments begin on page 2 of this paper.

Authorization begins on page 10 of this paper.

Docket No. 100718.124 (MIC-58DV2)

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :  
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                           Tianhong Zhang, et al. :  
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                           :  
                           Serial No. 09/722,400         Group Art Unit: 1756  
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                           :  
                           Filed: November 27, 2000         Examiner: Mohamedulla, Saleha R.  
                           :  
                           :  
                           For: POLYIMIDE AS A MASK IN VAPOR HYDROGEN FLUORIDE ETCHING

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**Transmittal Letter**

Submitted herewith for appropriate consideration by the U.S. Patent Office is the following document:

1. Petition for Extension of Time (three months); and
2. Response.

The Commissioner is authorized to charge the fee of \$1020 to Deposit Account No. 08-0219. The Commissioner is authorized to charge any other fees or credit any overpayments to Deposit Account No. 08-0219.

Respectfully submitted,

Leonid D. Thenor  
Registration No. 39,397

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Date: May 12, 2005